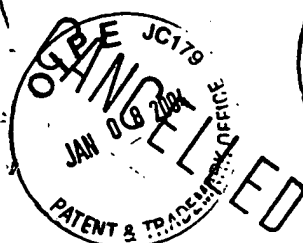


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LINDA E. HASTINGS

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Attorney Docket No.: NECK 17.552 (100806-17282)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner: Timothy J. Sutton

Group Art Unit: 2813

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

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AMENDMENT UNDER 37 C.F.R. 1.116

SIR:

In response to the Office Action mailed on October 7, 2003, the period for responding thereto having been set to expire after January 7, 2004, please amend the subject application as follows: